



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

A.	
	2814
1	-fw

in re Patent Application of:)	
Shunpei YAMAZAKI)	Group Art Unit: 2814
Serial No. 09/620,968)	
Filed: July 20, 2000)	Examiner: Nathan W. Ha
For: METHOD OF FORMING INSULATING FILMS, CAPACITANCES, AND SEMICONDUCTOR DEVICES)	Confirmation No.: 4214

RESPONSE AFTER FINAL OFFICE ACTION

U.S. Patent & Trademark Office 2011 South Clark Place Customer Window, **Mail Stop AF** Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Dear Sir:

The following is presented in response to the final Office Action mailed May 5, 2004, in connection with the above-captioned patent application.



TRANSMITTAL FORM

 $(to\ be\ used\ for\ all\ correspondence\ after\ initial\ filing)$

Total Number of Pages in This Submission

Application Number 09/620,968

Filing Date July 20, 2000

First Named Inventor Shunpei YAMAZAKI

Group Art Unit 2814

Examiner Name Nathan W. Ha

Attorney Docket Number 740756-2183

Confirmation Number 4214

Typed or printed name

		Confirmation Number	4214		
ENCLOSURES (check all that apply)					
Firm or Individual name Signature	SIGNATU Jerome W Nixon Pea	required or credit any overpa above identified docket num RE OF APPLICANT, ATTORNEY, O Massie, Registration No. 48,118 abody LLP eet, N.Y., Suite 900 on, D.C. 20004-2128			
CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR 1.8(a)]					
I hereby certify that this correspondence is being:					
deposited with the class mail in an env Alexandria, VA 22	United Stat velope addr 313-1450 imile on th	tes Postal Service on the date shown b	nmissioner for Patents, P. O. Box 1450,		
Date			Signature		